



Figure 1: Dynamic sensor response of a 50 nm MoO_x film deposited at 275 °C: a) complete measurement against six different concentrations of H₂ (5000–35000 ppm) and two different exposure times (1 and 15 min) and b) a more detailed view of the 15 min 25000 ppm H₂ pulse along with the extracted sensor performance. The measurements were done at 120 °C.[3]

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